

# Resource Summary Report

Generated by [dkNET](#) on Aug 16, 2026

## JEOL: JEBG-1000UB High Power Electron Beam Source

RRID:SCR\_020169

Type: Tool

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### Proper Citation

JEOL: JEBG-1000UB High Power Electron Beam Source (RRID:SCR\_020169)

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### Resource Information

**URL:** <https://www.jeolusa.com/PRODUCTS/Industrial-Equipment/High-Power-Electron-Beam-Sources>

**Proper Citation:** JEOL: JEBG-1000UB High Power Electron Beam Source (RRID:SCR\_020169)

**Description:** High power electron beam source that is designed to uniformly deposit metal oxides onto wide plastic films or steel plates in continuous feed such as in magnetic tape manufacture for high density recording or in wrapping film manufacture with oxide barrier function

**Resource Type:** instrument resource

**Keywords:** Jeol, JEOL, High Power Electron Beam Source, Instrument Equipment, USEDit,

**Availability:** Commercially available

**Resource Name:** JEOL: JEBG-1000UB High Power Electron Beam Source

**Resource ID:** SCR\_020169

**Alternate IDs:** Model\_Number\_JEBG-1000UB

**Record Creation Time:** 20220129T080349+0000

**Record Last Update:** 20260815T182633+0000

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### Ratings and Alerts

No rating or validation information has been found for JEOL: JEBG-1000UB High Power Electron Beam Source.

No alerts have been found for JEOL: JEBG-1000UB High Power Electron Beam Source.

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## Data and Source Information

**Source:** [SciCrunch Registry](#)

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## Usage and Citation Metrics

We have not found any literature mentions for this resource.